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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/698,007	10/30/2003	2812	0.00	P05718 P05717	4	22	2

CONFIRMATION NO. 7412

23990
 DOCKET CLERK
 P.O. DRAWER 800889
 DALLAS, TX 75380

FILING RECEIPT



OC000000011794037

Date Mailed: 01/30/2004

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Applicant(s)

Darren Lee Rust, Arlington, TX;
 George W. Logsdon, Arlington, TX;

Assignment For Published Patent Application

NATIONAL SEMICONDUCTOR CORPORATION, Santa Clara, CA;

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted: 01/29/2004

Projected Publication Date: Request for Non-Publication Acknowledged

Non-Publication Request: Yes

Early Publication Request: No

Title

Semiconductor wafer fabrication furnace idle monitor and method of operation

DOCKETED

FEB - 4 2004

RECEIVED

FEB - 4 2004

DAVIS MUNCK

Preliminary Class

438

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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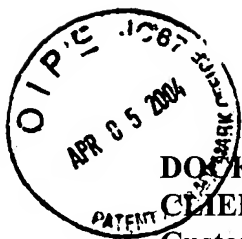
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DOCKET NO.: P05717
CLIENT NO.: NATI15-05717
Customer No. 23990

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : DARREN LEE RUST, ET AL.
U.S. Serial No. : 10/698,007
Filed : October 30, 2003
For : SEMICONDUCTOR WAFER FABRICATION FURNACE IDLE
MONITOR AND METHOD OF OPERATION
Group No. : 2812
Examiner : (Not Yet Assigned)

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Sir:

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

In reviewing the file, it has been noted that the Official Filing Receipt contains a typographical error in the Attorney Docket Number. The Docket Number should be corrected to read as follows:

-- P05717--

DOCKET NO.: P05717
SERIAL NO. 10/698,007
PATENT

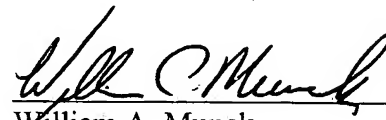
redlined copy of the Official Filing Receipt is attached. Once the correction is made, please forward a new filing receipt to the undersigned attorney at the below identified address.

Respectfully submitted,

DAVIS MUNCK, P.C.

Date:

March 30, 2004



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